



2161

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Christian Wagner et al.      Art Unit : 2161  
Serial No. : 09/934,817      Examiner : Etienne Pierre Leroux  
Filed : August 21, 2001      Conf. No. : 9363  
Title : OPTICAL ARRANGEMENT AND PROJECTION EXPOSURE SYSTEM FOR  
MICROLITHOGRAPHY WITH PASSIVE THERMAL COMPENSATION

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF FEBRUARY 27, 2007

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

3/15/07  
Date of Deposit

Terra Hatch  
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Typed or Printed Name of Person Signing Certificate